

Abstract

Method for roughening a surface of a body, and optoelectronic component

The invention relates to a method for roughening a surface of a body (1), having the following steps of: coating the surface with a mask layer (2), applying preformed mask bodies (3) on the mask layer (2), etching through the mask layer (2) at locations not covered by mask bodies (3), etching the body (1) at locations of its surface that are free of the mask layer (2). The invention furthermore relates to an optoelectronic component. By using the mask layer (2) as an additional auxiliary mask, it is possible to use methods having low selectivity with respect to polystyrene balls for etching.

Figure 1